	Approved For Release 2002/08/20 : CIA-RDP78B04747A002700030068-6	25X1
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	26 September 1967	
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•	Subject: Request for Funding	25X ²
	Dear Sir:	20/(
	As a result of the activities of this contract. In close coordination with the technical representatives of your organization over the past several months, and the meeting held at your facility on the same subject on 7 September 1967 submits herewith a request for funding to accomplish further effort on the subject contract and to accomplish added tasks to improve the systems.	25X1
STAT	We have divided the funding request into several individual parts with supporting cost sheets for each. The overrun funding request attached hereto is for the full amount estimated to accomplish the overrun tasks. This contractor understands that the actual contractual funding will be only 75% of that shown. The request for added task funds is made using overhead and G & A rates as covered by the negotiations under subject contract. i.e. a fixed overhead rate of The alignment microscope	·
	and training program are separate and distinct (and in the case of the microscope involves commercial products); these are being submitted at our current rates rather than the fixed contractual rates.	· .
	The request for funding, as applicable to the machine, is covered in Exhibit "A" for the accomplishment of the following tasks on the five machines as originally delivered under subject contract. Our activities will be to fabricate and install in three separate operations, i.e., accomplishment on the first two machines presently at	25X1 25X1
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Declass Review by NIMA / DoD

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25X1	our facility, on another group of two machines to be delivered to these facilities upon acceptance of the first two, and thirdly, to be accomplished on the last machine at the same time they are accomplished on the machine after the delivery of the second two machines.
	The overrun tasks to be accomplished are as follows:
	a. Fabricate new mounting mechanisms for improved operation of negator.springs.
	b. Redesign of the curtain assembly for improved operation.
	c. Reduce warm-up time (ready light) for power turn-off (inadvertent) to minimize stabilizing time rather than full 45 minute warm-up upon initial turn-on.
	d. Replacement of nameplate on front panel from 3/8 amp to 3/4 amp.
	c. Update manual of operating procedures to the equipment's latest configuration.
	f. Update drawings as provided by the contract to depict final configuration.
	The following added tasks, applicable to the machines, are 25X herewith provided with cost analyses noted below.
	Exhibit "B" covers the following added tasks.
	a. Modification of the head rest structure for improved support.
	b. Providing an access cover for ventilation and viewing of the pump assembly (water level).
	c. Access cover in machine sheet metal cover for adjustment of X axis interferometer.
	d. Access cover in sheet metal cover and headrest support for adjustment of Y axis interferometer.
	e. Wiring and placement of test points on front panel of digitizer for checking voltage level on Schmitt trigger circuits. This

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	requires relocation of high voltage potentiometers to the front panel. Study has shown that the high voltage potentiometer value and resolution are correct as designed, and we recommend no change.	
	f. Installation of chassis guide rails for easier access to both digitizer chasses.	·
25X1	Exhibit "C" covers the cost of adding a knee guide to the center opening of the machines to prevent the operator's knees from touching the working table.	
	Exhibit "D" covers supplying of an alignment microscope which can be used with any of the interferometers provided on the contracts. This microscope is used to align the interferometers with the basic working tables. It is an item which is also offered as an option to our commercial interferometer customers.	25X1
	Exhibit "E" covers the cost for conducting a training program at our facility for your calibration and maintenance personnel.	
•	A description of the training program is contained in Exhibit "F". It is our suggestion that this training program be conducted during the system test phase when the second two 405 machines are modified and assembled in our plant.	
25X1	Exhibit "G" contains a list of our recommended spare parts for maintaining both the machines, with unit prices and totals applicable to quantity recommended.	
25X1	Exhibits "H-1" and "H-2" cover costs to modify the machine to make it equal to the machines with the added tasks as recommended above. (Exhibits H-1 and H-2 relate respectively to Exhibits B and C.) In addition to the added tasks as described above, the following tasks will also be accomplished.	25X1
25X1	a. Modification of the microscope focus mechanisms equivalent provide improved reliability and minimize backlash. If a new design is desired, a separate quotation will be prepared.	4.
	b. Modification of the general illumination to improve the cut-off of the light on the chip format.	
25X1	It should be pointed out that the spare parts list, the alignment microscope, and the training program suggested above are equally applicable	

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		TRAINING PROGRAM	25X1
	Fo	r three (3) or four (4) customer trainees -	
•	I	Lecture Sessions	
25X1	•	 Theory Operation Maintenance a)nechanisms b) Interferometer Optics-Tracking 	
:5X1	II	c) Electronic System Shop Sessions - using two (2) Machines	
25X1		 Standard daily and weekly Test Procedures Standard weekly Adjustment Procedure Special repeatability measurement with grid. Alignment and Tracking - onsupplied Interferome Electronic Adjustment, Maintenance, and Trouble Shoot (usingsupplied System) 	
		 a) Photomultiplier b) Preamplifiers c) Difference amplifiers d) Schmitt triggers e) Pulse generators f) Cooling System g) Automatic compensator 	

